



12-10-03

1752

Attorney's Docket No. 5576-137

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Satoshi Watanabe  
Serial No.: 10/052,687  
Filed: January 18, 2002  
For: *RESIST MATERIAL AND PATTERN FORMING METHOD*

Confirmation No.: 3765  
Group Art Unit: 1752  
Examiner: Thornton, Yvette C.

PATENT  
**RECEIVED**  
DEC 16 2003  
TC 1700

Date: December 9, 2003

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REMARKS TO OFFICE ACTION**

Sir:

These remarks are responsive to the Office Action ("Action") dated September 10, 2003 and are filed before expiration of the three month shortened statutory period. Applicants provide the present remarks to address the issues raised in the Action pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.